



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroimi OTOMA

Group Art Unit: 2828

Application No.: 10/826,354

Filed: April 19, 2004

Docket No.: 119498

For: SURFACE EMITTING SEMICONDUCTOR LASER AND COMMUNICATION SYSTEM
USING THE SAME

CLAIM FOR PRIORITY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The benefit of the filing date of the following prior foreign application filed in the following foreign country is hereby requested for the above-identified patent application and the priority provided in 35 U.S.C. §119 is hereby claimed:

Japanese Patent Application No. 2003-122697 filed on April 25, 2003

In support of this claim, a certified copy of said original foreign application:

☒ is filed herewith.

It is requested that the file of this application be marked to indicate that the requirements of 35 U.S.C. §119 have been fulfilled and that the Patent and Trademark Office kindly acknowledge receipt of this document.

Respectfully submitted,

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Date: July 29, 2004

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